



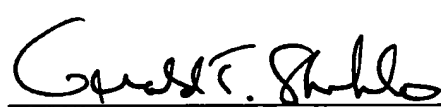
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PATENT  
Attorney Docket No. 1110/82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application	)	Confirmation No.: 6761
	)	
Applicant: Kozo Nakamura, et al.	)	
	)	<i>I hereby certify that this correspondence is</i>
Serial No.: 09/856,212	)	<i>being deposited with the United Postal</i>
	)	<i>Service as first class mail in an envelope</i>
Filed: May 18, 2001	)	<i>addressed to: Mail Stop AMENDMENT,</i>
	)	<i>Commissioner of Patents, P.O. Box 1450,</i>
For: PRODUCTION METHOD	)	<i>Alexandria, VA, 22313-1450.</i>
FOR SILICON SINGLE	)	
CRYSTAL AND	)	<u>June 28, 2006</u>
PRODUCTION DEVICE FOR	)	
SINGLE CRYSTAL INGOT,	)	
AND HEAT TREATING	)	
METHOD FOR SILICON	)	Gerald T. Shekleton Reg. No. 27,466
SINGLE CRYSTAL WAFER	)	
	)	
Examiner: Matthew J. Song	)	
	)	
Art Unit: 1722	)	

AMENDMENT

Mail Stop AMENDMENT  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of March 3, 2006 has been carefully reviewed and the following amendments and remarks are made in response thereto.